

# Search Notes



Application/Control No.

10/723,912

Examiner

Gabriel L. Chu

Applicant(s)/Patent under Reexamination

EVOY, JERRY MICHAEL

Art Unit

2114

## SEARCHED

Class	Subclass	Date	Examiner
714	37	1/12	RC
	39	1/12	RC

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
09/448232	1/12	RC
Term Search	1/12	RC
714/47 and compare with snapshot	1/12	RC